

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Liqun Chen, et al.	)	Re: Information Disclosure
	)	Statement
U.S. Appln. No.: 09/936,132	)	Group:2121
	)	
U.S. Filing Date: September 4, 2001	)	Examiner: not yet assigned
	)	
	)	Our Ref: B-4294PCT 619054-4
	)	
Topic: "COMPUTING APPARATUS AND	)	
METHODS USING SECURE	)	
AUTHENTICATION ARRANGEMENTS"	)	Date: February 19, 2003

Hon. Commissioner of Patents and Trademarks  
Washington, D.C. 20231

Sir:

In accordance with the Applicants' duty to disclose information which may be material to the examination of this application, the undersigned respectfully requests that the Examiner consider on the merits the documents listed on the enclosed Form PTO-1449 (modified) before issuing the first Office Action on the merits. We are enclosing herewith a copy of each document listed on the enclosed Form PTO-1449 (modified).

The Applicants believe that this IDS is being submitted before the issuance of a first Office Action on the merits and before the issuance of a Final Rejection or Notice of Allowance. Therefore, no official fees should be due; and this IDS should be considered on the merits. If this IDS is being submitted after the issuance of the first Office Action on the merits and before the issuance of a Final Rejection or Notice of Allowance, please contact the undersigned to authorize a payment of \$180.00 (or any other required amount), which is the fee set forth in 37 C.F.R. § 1.97(c), if the Examiner believes that such a fee is due in order for this IDS to be considered on the merits.

The filing of this Information Disclosure Statement shall not be construed as an admission against interest in any manner. (Notice of January 9, 1992, 1135 O.G. 13-25, at 25.) The filing of this Information Disclosure Statement (IDS) shall not be construed as a representation that a search has been made (37 C.F.R. 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability, or that no other material information



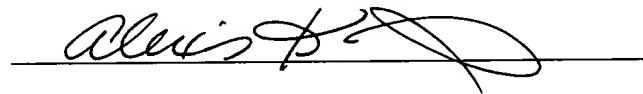
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exists.

The person making this statement is the practitioner who signs below on the basis of information supplied by an individual associated with the filing and prosecution of this application (37 C.F.R. § 1.56(c)) and on the basis of information in the practitioner's file.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first-class mail in an envelope addressed to the "Hon. Commissioner of Patents and Trademarks, Washington, D.C. 20231", on February 19, 2003 by Alexis Karriker.



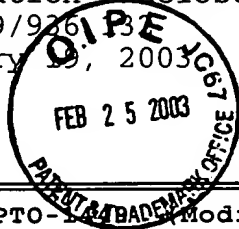
Respectfully submitted,



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Enclosures: Form PTO-1449 (modified) (1 page)  
Copy of documents listed on Form PTO-1449 (modified)



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Form PTO-1 (Modified)	ATTY DOCKET NO. B-4294PCT 619054-4	U.S. SERIAL NO. 09/936,132
LIST OF PATENTS AND PUBLICATIONS STATEMENT	APPLICANTS Liqun Chen, et al.	
	FILING DATE September 4, 2001	GROUP 2121

**U.S. PATENT DOCUMENTS**

examiner initial	document number	issue date	name	class	sub- class	filing date or 102(e) date if appropriate
	5,379,344	1/95	Larsson et al.	380	23	

**FOREIGN PATENT DOCUMENTS**

examiner initial	document number	publication date	country	class	subclass	translation yes/no
	0 992 958 A2	4/00	EP			
	1 081 891 A2	3/01	EP			

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

	Yee, B., "Using Secure Coprocessors," Doctoral thesis - Carnegie Mellon University, pp 1-94 (May 1994).	
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EXAMINER	DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.